Electronic Acknowledgement Receipt

EFS ID:	2962878
Application Number:	10711310
International Application Number:	
Confirmation Number:	5309
Title of Invention:	Method of Managing Wafer Defects
First Named Inventor/Applicant Name:	Hung-En Tai
Customer Number:	27765
Filer:	Winston Hsu
Filer Authorized By:	
Attorney Docket Number:	LKSP0051USA
Receipt Date:	10-MAR-2008
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Time Stamp:	21:20:21
Application Type:	Utility under 35 USC 111(a)

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Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	$460
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Amendment - After Non-Final Rejection	LKSP0051USA_A2_1_amend.pdf	647460 fb87b456f9026f1374c064e92ecb2b962ad00821	no	1
Warnings:					
Information:					
2	Specification	LKSP0051USA_A2_1_spec.pdf	647443 ba829f430a6ec93b937bc035219f7c0984d84e61	no	2
Warnings:					
Information:					
3	Claims	LKSP0051USA_A2_1_claim.pdf	647424 3dec155d74880aa3f45150bd0022b2c4facdcf03	no	3
Warnings:					
Information:					
4	Applicant Arguments/Remarks Made in an Amendment	LKSP0051USA_A2_1_remarks.pdf	647443 44773e46680f426483eae36a25a904e7bf9d8473	no	2
Warnings:					
Information:					
5	Extension of Time	LKSP0051USA_A2_1_extension.pdf	647468 b1745392e0fba251a696c285bb9dfdb30287c1fa	no	1
Warnings:					
Information:					
6	Fee Worksheet (PTO-06)	fee-info.pdf	8123 bcb138a2c37bf25da4a0c3e13413ed996927a641	no	2
Warnings:					
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		Total Files Size (in bytes):	3245361		

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If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

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